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APPLICANTS Soon-Il Ahn, Busan, KOREA, REPUBLIC OF; Byoung-Sun Na, Hwaseong-gun, KOREA, REPUBLIC OF; Jeong-Young Lee, Yongin-si, KOREA, REPUBLIC OF; You-Lee Song, Seoul, KOREA, REPUBLIC OF;						
** CONTINUING DATA ***** ** FOREIGN APPLICATIONS ***** REPUBLIC OF KOREA 2003-42850 06/27/2003 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 06/17/2004						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance PEP	STATE OR COUNTRY	SHEETS DRAWINGS	TOTAL CLAIMS	INDEPENDENT CLAIMS
Verified and Acknowledged	/PAMELA E PERKINS/ Examiner's Signature	Initials	KOREA, REPUBLIC OF	34	19	3
ADDRESS F. CHAU & ASSOCIATES, LLC 130 WOODBURY ROAD WOODBURY, NY 11797 UNITED STATES						
TITLE Method of exposing layer with light and method of manufacturing thin film transistor substrate for liquid crystal display device using the same						
FILING FEE RECEIVED 1504	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			<input type="checkbox"/> All Fees		
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